

<b>Notice of References Cited</b>	Application/Control No. 10/775,017	Applicant(s)/Patent Under Reexamination FUJIWARA ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0026736	02-2004	Grupp et al.	257/330
*	B	US-2004/0256647	12-2004	Lee et al.	257/289
*	C	US-2004/0219722	11-2004	Pham et al.	438/157
*	D	US-2004/0110331	06-2004	Yeo et al.	438/199
*	E	US-2004/0217420	11-2004	Yeo et al.	257/347
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	K	US-			
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

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